Docket No.: M4065.0319/P319-A (PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Husam N. Al-Shareef, et al.

Application No.: Not Yet Assigned

Group Art Unit: N/A

Filed: July 26, 2001

Examiner: Not Yet Assigned

For: FABRICATION OF DRAM AND OTHER SEMICONDUCTOR DEVICES WITH AN INSULATING FILM USING A WET RAPID THERMAL OXIDATION PROCESS

FIRST PRELIMINARY AMENDMENT

Box Non-Fee Amendment

Commissioner for Patents Washington, DC 20231

Dear Sir:

Prior to examination on the merits, please amend the above-identified U.S. patent application as follows:

In the Specification

Page 1, after the title, please insert -- This application is a divisional of application Ser. No. 09/296,835, filed on April 22, 1999, which is hereby incorporated by reference.--

In the Claims

Please cancel claims 1-12.

REMARKS/ARGUMENTS

The specification has been amended to include a reference to prior application Ser. No. 09/296,835, filed on April 22, 1999, as required by 37 CFR 1.78(a)(2).

Claims 1-12 have been canceled. The pending application now contains claims 13-40.

By

Allowance of the application is solicited.

Dated: July 26, 2001

Respectfully submitted,

Thomas J. D'Amico

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